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In re Application of: Junichi HIKITA

Application No.: 10/626,524

Filing Date: July 25, 2003

Title: METHOD OF PRODUCING A SEMICONDUCTOR DEVICE BY DIVIDING  
A SEMICONDUCTOR WAFER INTO SEPARATE PIECES OF SEMICONDUCTOR  
CHIPS (as amended)

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October 17, 2005  
Date

Steven M. Rabin  
Signature

Steven M. Rabin- Reg.No.29,102  
Typed or printed name

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80246-0072

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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/626,524 ✓				1133

7590

09/15/2005

Rader Fishman & Grauer  
39533 Woodward Avenue  
Suite 140  
Bloomfield Hills, MI 48304

EXAMINER
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ART UNIT	PAPER NUMBER
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DATE MAILED: 09/15/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

**RECEIPT NO. 21766**

**DATE:**

**July 22, 2005**

**ATTY. DOCKET:**

**AI 290 D1**

**APPLICANT: Junichi HIKITA**

**SERIAL NO.: Divisional of 09/704,563**

**FILED: July 25, 2003**

**FOR: METHOD OF PRODUCING A SEMICONDUCTOR  
DEVICE BY DIVIDING A SEMICONDUCTOR WAFER  
INTO SEPARATE PIECES OF SEMICONDUCTOR CHIPS  
(AS AMENDED)**

**PAPERS FILED:**

**STATUS REQUEST**

**FEE: \$0.00**

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RECEIPT NO. 21766

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RECEIPT NO. 20079

DATE:

February 8,  
2005

ATTY.

AI 290 D1

DOCKET:

APPLICANT(S): Junichi HIKITA

SERIAL NO.: Divisional of 09/704,563

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ATTN: TICKET NO.: RC-0031/DIV  
(80246-0072)

Inventor: Junichi HIKITA, et al.

Application No.: Not Yet Assigned

Filing Date: July 24, 2003

TITLE: METHOD OF PRODUCING A SEMICONDUCTOR DEVICE BY DIVIDING A  
SEMICONDUCTOR WAFER INTO SEPARATE PIECES OF SEMICONDUCTOR CHIPS  
(AS AMENDED)

Documents Filed:

Transmittal-New Utility Patent Application (in duplicate) Preliminary Amendment

Fee Transmittal (in duplicate)

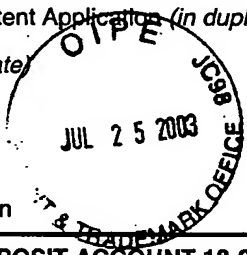
Information Disclosure Statement

Specification (44 pages)

Form PTO/SB/08A

Drawings (10 sheets)

Copy of Oath or declaration



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**MAIL STOP PATENT APPLICATION**

Sender's Initials: YY/CS/ddd

Date filed in the USPTO: July 24, 2003

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